

10/565653

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IAP20 Rec'd PCT/PTO 24 JAN 2006

In re the Application of

Koichi KANAYA et al.

Application No.: New U.S. National Stage of PCT/JP2004/006007

Filed: January 24, 2006

Docket No.: 126247

For: VAPOR DEPOSITION APPARATUS AND VAPOR DEPOSITION METHOD

INFORMATION DISCLOSURE STATEMENT

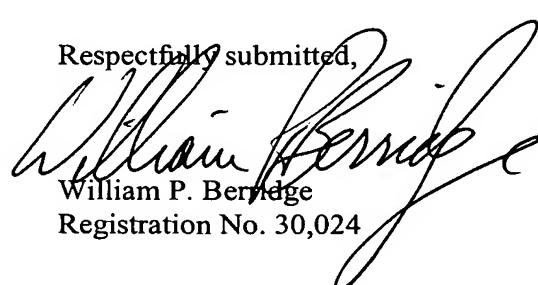
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- 2. Relevance of references 7-8 is discussed in the present specification.
- 3. References 1-6 were cited in the International Search Report. An English language version of the International Search Report is attached for the Examiner's information.
- 4. English language Abstracts of the non-English language references are attached hereto.
- 5. Computer-generated English language translations of the following Japanese references have been obtained from the website of the Japanese Patent Office ([\[http://www.jpo.go.jp\]](http://www.jpo.go.jp)), and are attached, but have not been reviewed for accuracy. See References 1-2 & 4-6.

Respectfully submitted,


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Date: January 24, 2006

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Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE	ATTY DOCKET NO. 126247	APPLICATION NO. New U.S. National Stage of PCT/JP2004/006007 10/565653
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)		APPLICANTS Koichi KANAYA et al.		
		FILING DATE January 24, 2006		

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS
	1.	JP-A-2003-203866 w/ abst. & trans.	07/18/2003	JAPAN		
	2.	JP-A-2003-197546 w/ abst. & trans.	07/11/2003	JAPAN		
	3.	JP-A-01-256118 w/ abst.	10/12/1989	JAPAN		
	4.	JP-A-06-302550 w/ abst. & trans.	10/28/1994	JAPAN		
	5.	JP-A-2002-134484 w/ abst. & trans.	05/10/2002	JAPAN		
	6.	JP-A-2000-269150 w/ abst. & trans.	09/29/2000	JAPAN		
	7.	JP-A-61-215289 w/ abst.	09/25/1986	JAPAN		
	8.	JP-A-62-262417 w/ abst.	11/14/1987	JAPAN		

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

EXAMINER	DATE CONSIDERED
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Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.